



INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

ATTY DOCKET NO.

ITL1023US (P16710)

SERIAL NO.

10/679,816

APPLICANT(S):

ROBERT BRISTOL ET AL.

FILING DATE:

October 6, 2003

GROUP ART UNIT:

1756

U.S. PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
INITIAL							
KAT	A.	5,158,861	10/27/1992	TOKUI ET AL.	430	325	
	B.						
	C.						
	D.						
	E.						
	F.						
	G.						
	H.						
	I.						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	J.							
	K.							
	L.							
	M.							
	N.							
	O.							
	P.							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

KAT	Q.	Cheng et al., "Improving Resist Resolution and Sensitivity Via Electric-Field Enhanced Postexposure Baking", J. Vac. Sci. Technol. B 20(2), Mar/Apr 2002
	R.	
	S.	
	T.	
	U.	
	V.	
	W.	

EXAMINER

K. Duda

DATE CONSIDERED

3-6-06

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)				ATTY DOCKET NO. ITL.1023US (P16710)		SERIAL NO. 10/679,816	
				APPLICANT(S): Robert Bristol et al.			
				FILING DATE: October 6, 2003		GROUP ART UNIT:	

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U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
(UAD)	A. 5,648,000	07/15/1997	Yamazaki et al.	—	—		
(UAD)	B. 5,783,362	07/21/1998	Wakiya et al.	—	—		
(UAD)	C. 6,103,145	08/15/2000	Angelopoulos et al.	—	—		
	D.						
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U.S. PATENT APPLICATION PUBLICATIONS							
(UAD)	F.	2002/0046703	04/25/2002	Templeton	—	—	
(UAD)	G.	2003/0008246	01/09/2003	Cheng et al.	—	—	
	H.						
	I.						
	J.						

FOREIGN PATENT DOCUMENTS								
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
(UAD)	K.	JP 57-32632	02/22/1982	Japan	—	—	Abstract Only	
(UAD)	L.	JP 63-71842	04/01/1988	Japan	—	—	Abstract Only	
(UAD)	M.	JP 63-244622	10/12/1988	Japan	—	—	Abstract Only	
(UAD)	N.	JP 10-106930	04/24/1998	Japan	—	—	Abstract Only	
	O.							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		
	P.	
	Q.	
	R.	
	S.	
	T.	
	U.	
	V.	

EXAMINER <i>K. Duda</i>	DATE CONSIDERED <i>3-6-06</i>
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